

<b>Notice of References Cited</b>	Application/Control No. 09/932,490	Applicant(s)/Patent Under Reexamination TEMOSHENKO ET AL.	
	Examiner Hong Cho	Art Unit 2662	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,321,336	11-2001	Applegate et al.	713/201
	B	US-6,335,930	01-2002	Lee, Hee-choul	370/387
	C	US-2002/0101867	08-2002	O'Callaghan et al.	370/389
	D	US-6,839,349	01-2005	Ambe et al.	370/390
	E	US-2002/0004819	01-2002	Agassy et al.	709/203
	F	US-2004/0199670	10-2004	Garfinkel, Simson L.	709/246
	G	US-6,529,515	03-2003	Raz et al.	370/401
	H	US-6,862,282	03-2005	Oden, Robert D.	370/394
	I	US-2002/0196785	12-2002	Connor, Patrick L.	370/392
	J	US-6,707,818	03-2004	Kadambi et al.	370/391
	K	US-2002/0054595	05-2002	Ambe et al.	370/390
	L	US-2002/0009079	01-2002	Jungck et al.	370/389
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.